

Electronic Acknowledgement Receipt

EFS ID:	1469483
Application Number:	10671922
International Application Number:	
Confirmation Number:	8459
Title of Invention:	Atomic layer deposition methods, and methods of forming materials over semiconductor substrates
First Named Inventor/Applicant Name:	Garo J. Derderian
Customer Number:	21567
Filer:	Jennifer J. Taylor
Filer Authorized By:	
Attorney Docket Number:	MI22-2296
Receipt Date:	26-JAN-2007
Filing Date:	24-SEP-2003
Time Stamp:	17:37:34
Application Type:	Utility

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	id5.pdf	38239	no	1

Warnings:

Information:

This is not an USPTO supplied IDS fillable form

2

Information Disclosure Statement
(IDS) Filed

ID6.pdf

657747

no

4

Warnings:**Information:**

Total Files Size (in bytes):

695986

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.